

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE



In re Patent Application of )  
Hisashi OHTANI et al. )  
Serial No. 09/197,767 )  
Filed: November 23, 1998 )  
For: SEMICONDUCTOR DEVICE AND )  
PROCESS FOR PRODUCING )  
THE SAME )

Art Unit: 2814  
Examiner: Phat X.Cao

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with  
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*Phat X. Cao*

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents  
Washington, DC 20231


Sir:

In accordance with the provisions of 37 C.F.R. 1.56 and 37 C.F.R. 1.97-1.99, Applicant submits herewith a Form PTO-1449 listing references known to Applicant and requests that these references be considered by the Examiner and made of record in the above identified application. Copies of the references listed are submitted herewith in accordance with 37 C.F.R. 1.98(a).

The attached references were cited in an Office Action dated May 6, 2002 in Application Serial No. 09/550,598.

The requisite fee of \$180 is attached hereto.

Respectfully submitted,

  
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